



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8915

SERIAL NUMBER 09/942,213	FILING DATE 08/30/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 501.40475X00
APPLICANTS Maki Tanaka, Yokohama, JAPAN; Masahiro Watanabe, Yokohama, JAPAN; Kenji Watanabe, Oume, JAPAN; Mari Nozoe, Hino, JAPAN; Hiroshi Miyai, Hitachi, JAPAN;				
** CONTINUING DATA ***** none JS				
** FOREIGN APPLICATIONS ***** JS JAPAN 2001-185773 06/20/2001				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/08/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>John Strong</i> Acknowledged <i>Examiner's Signature</i> JS Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 19	TOTAL CLAIMS 18
				INDEPENDENT CLAIMS 3
ADDRESS 020457				
TITLE Method and apparatus for inspecting a semiconductor device				
FILING FEE RECEIVED 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	